

Notice of References Cited	Application/Control No. 10/739,351	Applicant(s)/Patent Under Reexamination TAKAHASHI ET AL.	
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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
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FOREIGN PATENT DOCUMENTS

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	N	WO 02/39493 A1	05-2002	PCT	Ogasawara et al	--
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NON-PATENT DOCUMENTS

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	U	WEBSTER'S II New Riverside University Dictionary, 1994, page 695 "linear".
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